

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q63956

Toshiaki KUNIYASU, et al.

Appln. No.: 09/826,851

Group Art Unit: 2828

Confirmation No.: 3185

Examiner: James Menefee

Filed: April 6, 2001

SEMICONDUCTOR LASER ELEMENT AND SEMICONDUCTOR LASER

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents Washington, D.C. 20231

Sir:

For:

In response to the Office Action dated September 10, 2002, Applicant hereby elects the

claims of Group I, including claims 1-7 and 18-21. This election with made without traverse.

Timely and favorable consideration on the merits is respectfully requested.

Respectfully submitted,

Registration No. 41,239

SUGHRUE MION, PLLC

2100 Pennsylvania Avenue, N.W.

Washington, D.C. 20037-3213 Telephone: (202) 293-7060

Facsimile: (202) 293-7860

Date: October 10, 2002

10, 2002, Applicant hereby elects the election with made without traverse.

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RECEIVED

RECHNOLOGY CENTER 2800

TECHNOLOGY CENTER 2800 SEMICONDUCTOR LASER ELEMENT AND SEMICONDUCTOR LASER

PRELIMINARY AMENDMENT

Commissioner for Patents Washington, D.C. 20231

Sir:

Prior to examination on the merits, please amend the above-identified application as

follows:

IN THE CLAIMS:

Please cancel claim 22 without prejudice or disclaimer.